

# PATENT ASSIGNMENT

Electronic Version v1.1

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<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT										
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT										
<b>CONVEYING PARTY DATA</b>											
<table border="1" style="width: 100%; border-collapse: collapse;"> <thead> <tr> <th style="width: 70%;">Name</th> <th style="width: 30%;">Execution Date</th> </tr> </thead> <tbody> <tr> <td>Cheng-Hsien WU</td> <td>01/13/2011</td> </tr> <tr> <td>Chih-Hsin KO</td> <td>01/13/2011</td> </tr> <tr> <td>Clement Hsingjen WANN</td> <td>01/18/2011</td> </tr> </tbody> </table>		Name	Execution Date	Cheng-Hsien WU	01/13/2011	Chih-Hsin KO	01/13/2011	Clement Hsingjen WANN	01/18/2011		
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<b>RECEIVING PARTY DATA</b>											
<table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 20%;"><b>Name:</b></td> <td>TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.</td> </tr> <tr> <td><b>Street Address:</b></td> <td>No. 8, Li-Hsin Rd. VI, Hsinchu Science Park</td> </tr> <tr> <td><b>City:</b></td> <td>Hsinchu</td> </tr> <tr> <td><b>State/Country:</b></td> <td>TAIWAN</td> </tr> <tr> <td><b>Postal Code:</b></td> <td>300</td> </tr> </table>		<b>Name:</b>	TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.	<b>Street Address:</b>	No. 8, Li-Hsin Rd. VI, Hsinchu Science Park	<b>City:</b>	Hsinchu	<b>State/Country:</b>	TAIWAN	<b>Postal Code:</b>	300
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<b>PROPERTY NUMBERS Total: 1</b>											
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<b>CORRESPONDENCE DATA</b>											
<p>Fax Number: (703)518-5499  <i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i></p> <p>Phone: 7036841111</p> <p>Email: sramunto@ipfirm.com</p> <p>Correspondent Name: Lowe Hauptman Ham &amp; Berner, LLP (TSMC)</p> <p>Address Line 1: 1700 Diagonal Road, Suite 300</p> <p>Address Line 4: Alexandria, VIRGINIA 22314</p>											
<b>ATTORNEY DOCKET NUMBER:</b>	T5057-B355U										
<b>NAME OF SUBMITTER:</b>	Benjamin J. Hauptman										
<p>Total Attachments: 1  source=efiledassgn#page1.tif</p>											

OP \$40.00 13009151

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**PATENT**  
**REEL: 025659 FRAME: 0694**

Docket No.: T5057-B355U

**ASSIGNMENT**

In consideration of the premises and other good and valuable consideration in hand paid, the receipt and sufficiency of which is hereby acknowledged, the undersigned,

- 1) **Cheng-Hsien WU**
- 2) **Chih-Hsin KO**
- 3) **Clement Hsingjen WANN**

who has made a certain new and useful invention, hereby sells, assigns and transfers unto

**TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.** having a place of business at **No. 8, Li-Hsin Rd. VI, Hsinchu Science Park, Hsinchu 300, Taiwan R.O.C.**

its successors and assigns (hereinafter designated "ASSIGNEE") the entire right, title and interest for the United States of America as defined in 35 U.S.C. 100 in the invention entitled

**SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD WITH IMPROVED  
EPITAXIAL QUALITY OF III-V COMPOUND ON SILICON SURFACES**

(a) for which an application for United States Letters Patent was filed on 1-19-2011, and identified by United States Patent Application No. 13/009,151; or

(b) for which an application for United States Letters Patent was executed on \_\_\_\_\_,

and the undersigned hereby authorizes and requests the United States Commissioner of Patents and Trademarks to issue any and all United States Letters Patent which may be granted therefore and any and all extensions, divisions, reissues, continuations, or continuations-in-part thereof, and the right to all benefits under the International Convention for the Protection of Industrial Property to the said ASSIGNEE, for its interest as ASSIGNEE, its successors, assigns and legal representatives; the undersigned agrees that the attorneys of record in said application shall hereafter act on behalf of said ASSIGNEE;

AND the undersigned hereby agrees to transfer a like interest, and to render all necessary assistance in making application for and obtaining original, divisional, reissued or extended Letters Patent of the United States, upon request of the said ASSIGNEE, its successors, assigns and legal representatives, and without further remuneration, in and to any improvements, and applications for patent based thereon, growing out of or related to the said invention; and to execute any papers by the said ASSIGNEE, its successors, assigns and legal representatives, deemed essential to ASSIGNEE's full protection and title in and to the invention hereby transferred.

SIGNED on the date indicated aside my signature:

1) Cheng-Hsien Wu  
Name: **Cheng-Hsien WU**

2011.1.13  
Date:

2) Chih-Hsin Ko  
Name: **Chih-Hsin KO**

2011.1.13  
Date:

3) Clement Hsingjen WANN  
Name: **Clement Hsingjen WANN**

2011.1.13  
Date: